

Novel Concepts for CO₂ Detection by Differential Resonant Nanosensing

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- EU-FP-7-“NEMSIC” project presentation
- State of the art –NEMS/MEMS resonant differential chemical sensors
- Honeywell concept
- Chemical sensing at nano-scale by numbers
- Novel concepts-All differential resonant chemical sensor
- Novel concept for CO₂ detection by all differential resonant approach
- Conclusions

EU-FP-7 "NEMSIC" project

About NEMSIC

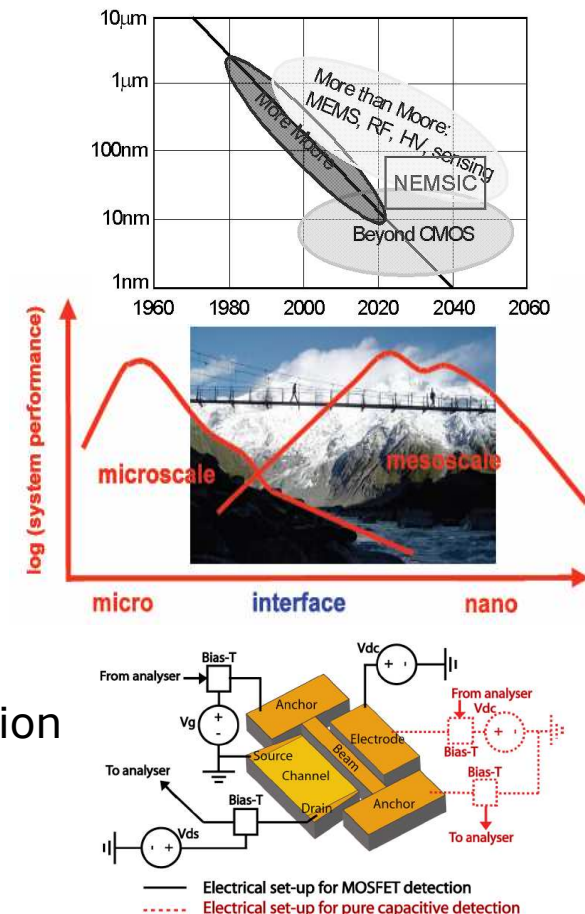
- "NEMSIC" was ranked no 1 out of 160 EU proposals on Nanotechnology-2008
- "Hybrid Nano-Electro-Mechanical/Integrated Circuit Systems for Sensing and Power Management Applications"
- Project coordinator : Prof. Adrian Ionescu-EPFL

Strategic objective

- Nanoelectronics with enhanced functionality (CO₂, NO₂, SO₂, DNA, proteins)
"More than Moore" nanosystems for gas/bio sensing
Novel NEM-FET switches for power management

Technical objectives

- NEMS-SOI-CMOSFET as a sensing technology platform
- Vibrating gate/Si body FET as a resonant nanosensor
- Ultra-high gas/bio sensitivities at room temperature operation

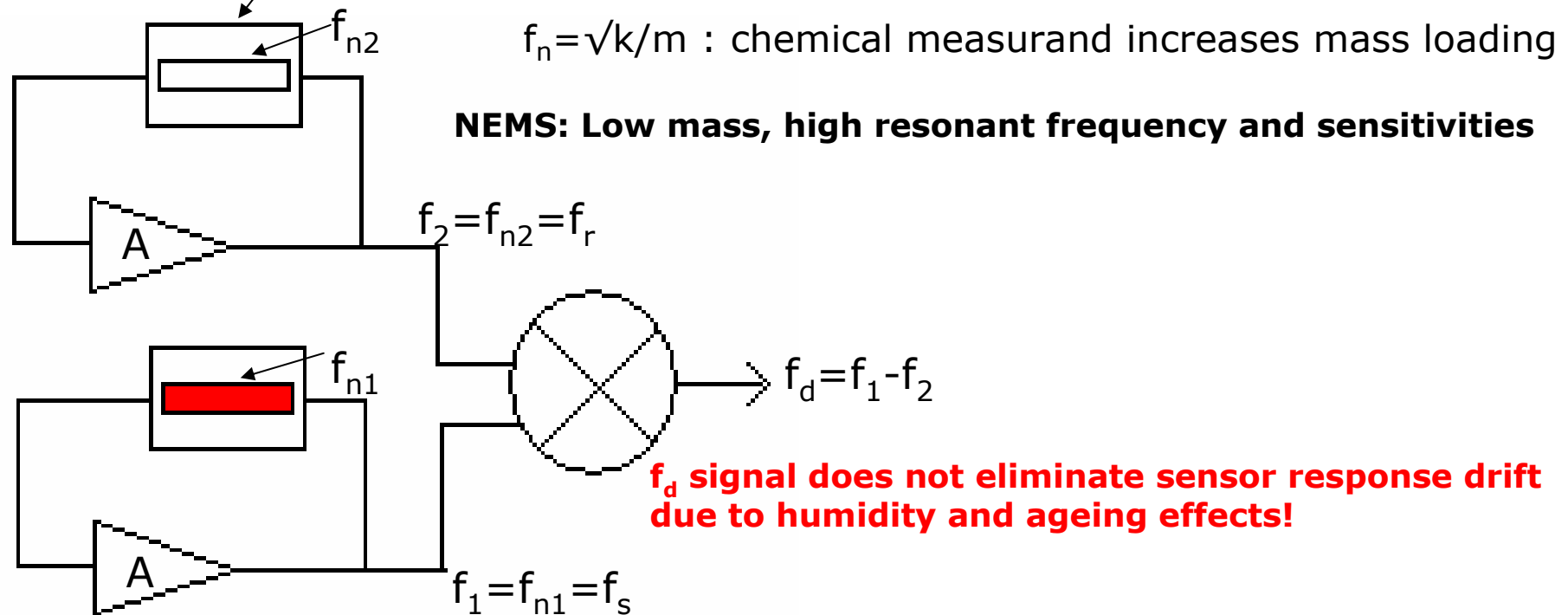


State of the art MEMS/NEMS resonant chemical sensor

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Differential resonant sensing: detected measurand shifts the resonance frequency

Uncoated vibrating MEMS beam in the feed-back loop of an amplifier



f_{n1} : mechanical resonance frequency of coated sensing beam

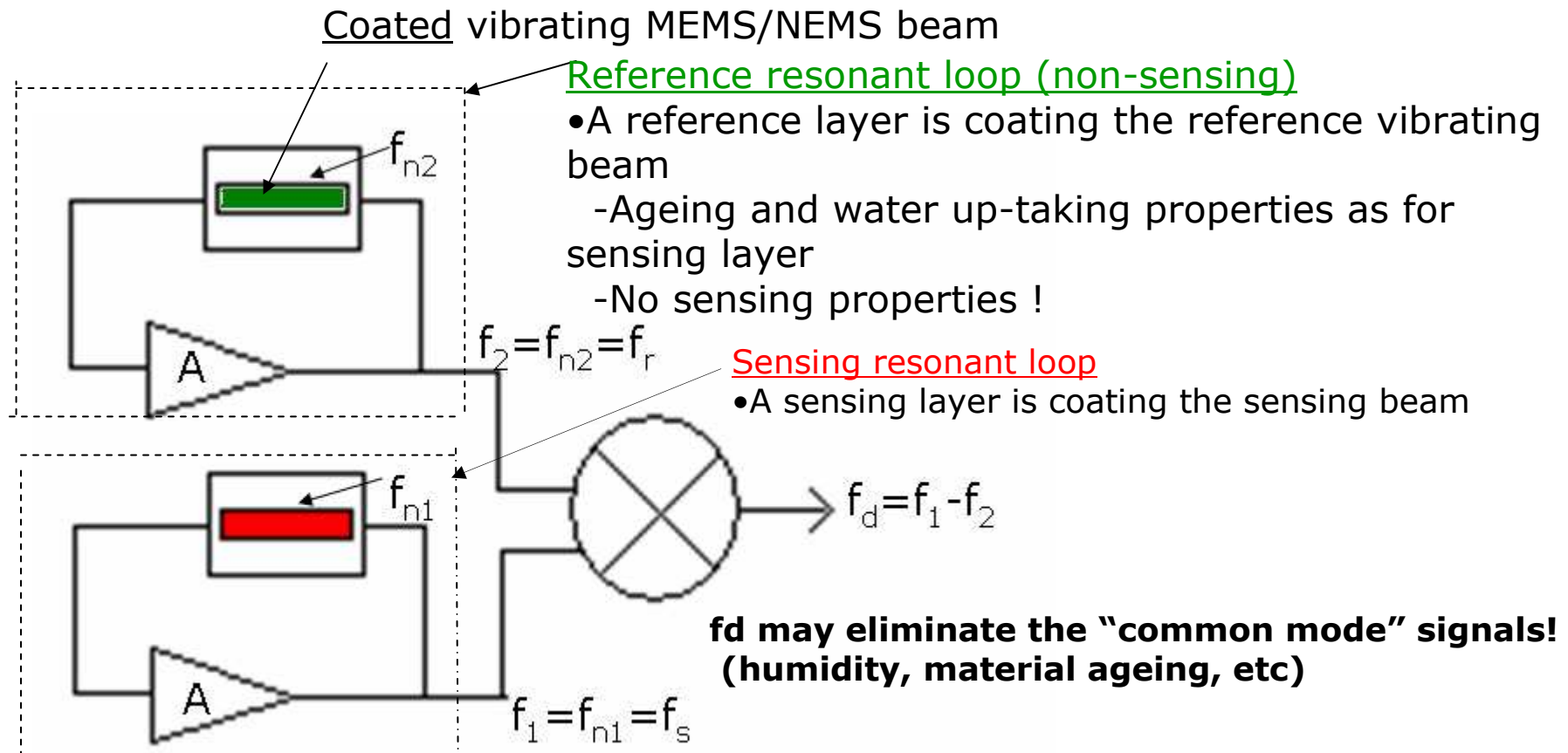
f_{n2} : mechanical resonance frequency of uncoated reference beam

f_1 : operating frequency of the sensing oscillator

f_2 : operating frequency of the reference oscillator

f_d : output frequency of the mixer providing sensor response to a chemical measurand

Honeywell's concept*

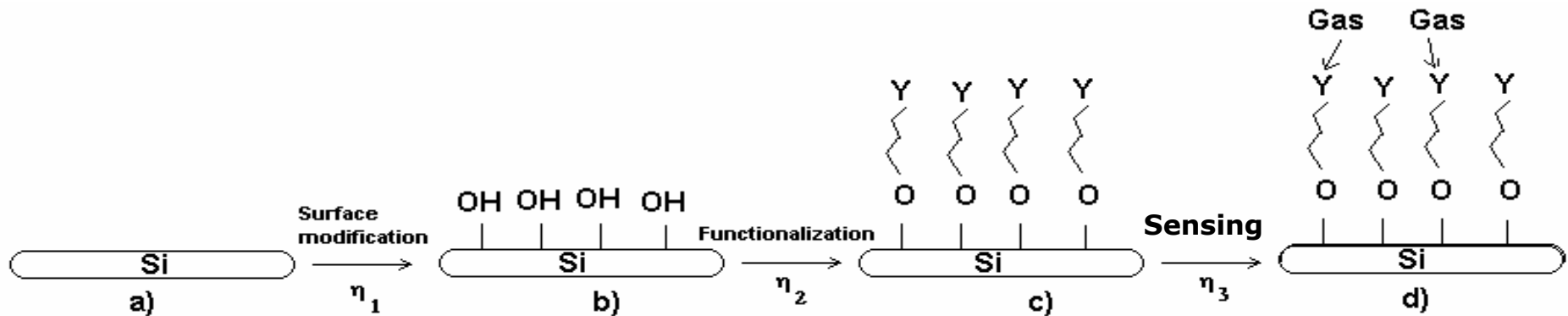


f_{n1} : mechanical resonance frequency of coated sensing beam
 f_{n2} : mechanical resonance frequency of coated reference beam (non-sensing layer)

*Cornel Cobianu, Bogdan Serban, "All-differential resonant nanosensor apparatus and method", U.S patent application, Application number: 12/617,893, Filing date: 11/13/09

Chemical sensing at nano-scale

- Sensing mono-layers should preserve low inertial mass of beam: $m=(1-20)$ fg
 ($L=2 \mu\text{m}$, $W=100 \text{ nm}$, $H=40\text{nm}$; $S_A=56 \times 10^{-10} \text{ cm}^2$)



Mass loading estimations for an optimistic scenario

Mass of vibrating beam: $m=18$ fg

$M_{\text{NO}_2} = 46$ g/mole;

$Ds=10^{15} \text{ cm}^{-2}$

$N_A = 6.023 \times 10^{23}$ molecules/mole

$$\delta m_{\text{gas}} = Ds \cdot S_A \cdot \eta_1 \cdot \eta_2 \cdot \eta_3 \cdot \frac{M}{N_A}$$

$$\eta_1 = \eta_2 = \eta_3 = 1/2$$

$$\delta m_{\text{gas}} = 5.3 \times 10^{-17} \text{ g} = 53 \text{ ag}$$

$$\frac{\delta m}{m} = \frac{5.3 \cdot 10^{-17}}{1.8 \cdot 10^{-14}} = 3 \cdot 10^{-3} = 2 \frac{f}{fo}$$

$\delta m/m$ could easily be in the range of 10^{-6} for ultra low gas concentrations !

C. Cobianu et al., CAS Conference 2009, Sinaia

- Clean Si surface is functionalized for CO₂ sensing.
- Self assembled monolayers (SAMs) with suitable sensing terminal groups at the surface of silicon are used.
- Design and/or selection of sensing materials were performed according to acid-base interaction (in the terms of Bronsted-Lowry theory or Hard-Soft Acid Base -theory).
- Functionalized sensing layer-in the sensing loop
- Functionalized reference layer-in the reference loop*.

****Cornel Cobianu, Bogdan Serban, "All-differential resonant nanosensor apparatus and method", U.S patent application, Application number: 12/617,893, Filing date: 11/13/09***

- Self-assembled monolayers (SAMs) have been used for the **functionalization** of the **silicon surface** for CO₂ sensing.
- The selection of the sensitive terminal groups which are incorporated in the SAMs was based on the **Hard Soft Acid Base (HSAB) rule**. According to the HSAB rule, since CO₂ is a hard acid, a hard base should be suitable for sensing it.
- **We have chosen amino-groups for the interaction with CO₂**. This interaction is an acid-base equilibrium, which is reversible and leads to the formation of carbamates.

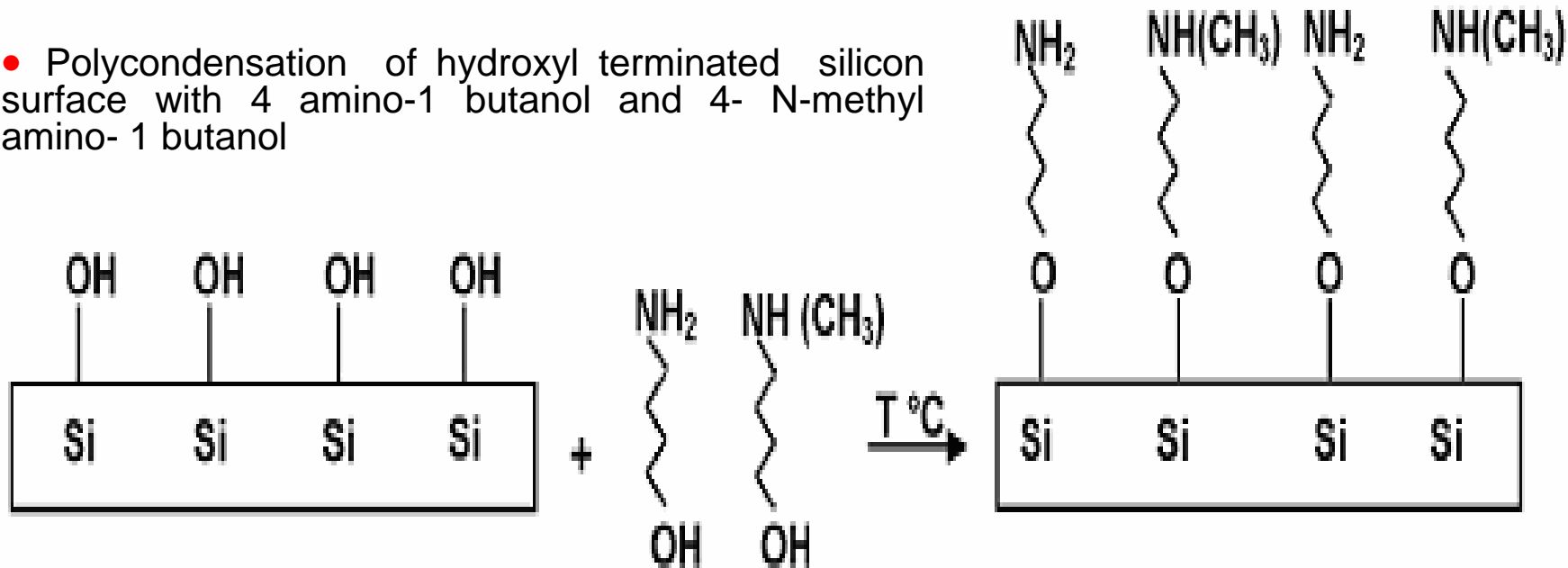
Functionalization for CO₂–First approach(2/4)

Honeywell

- Amino-alcohol compounds to be used*

•*Bogdan Serban, Cornel Cobianu, Mihai N. Mihaila, Viorel Georgel Dumitru, "Functionalized monolayers for carbon dioxide detection by a resonant nanosensor", U.S patent provisional application, Application number: 61/262,702, Filing date: 11/19/2009

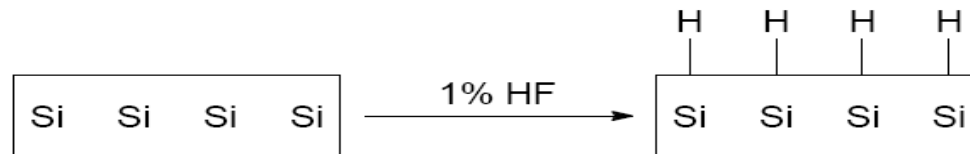
- Polycondensation of hydroxyl terminated silicon surface with 4 amino-1 butanol and 4- N-methyl amino- 1 butanol



Functionalization for CO₂ – First approach(3/4)

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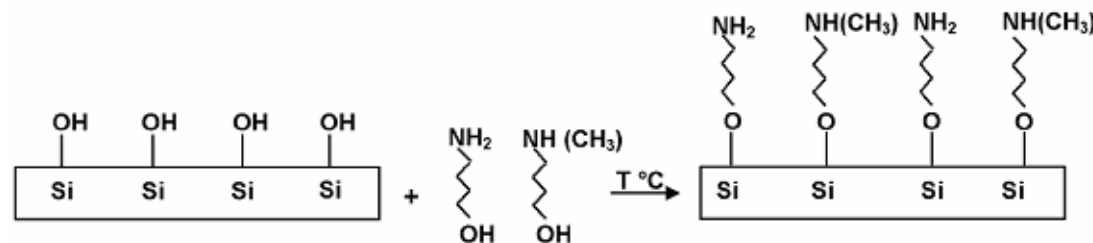
- Processed Si wafer cleaning in isopropyl alcohol and DI Water
- Native oxide removal from the Si wafer and formation of Si-H bonds on Si surface



- Ozone exposure in order to obtain a hydroxyl terminated surface

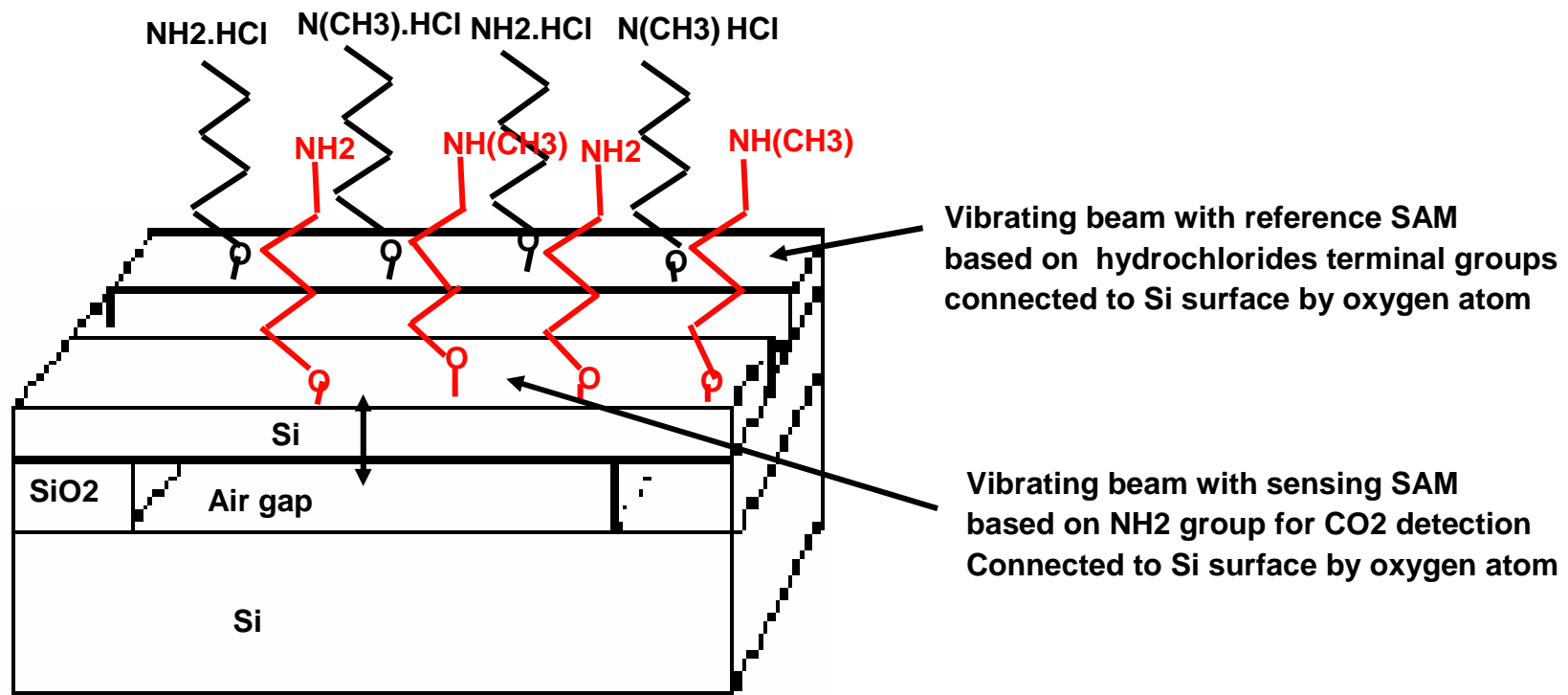


- Immersion in a sealed flask containing 4-amino-1-butanol and 4-N-methylamino-1-butanol



Reference layer functionalization 4/4

-Reaction of the above layer with HCl to get a reference layer on the reference beam

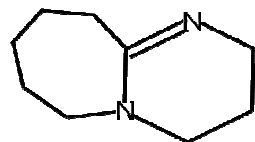


Functionalization for CO₂ – Second approach (1/3)

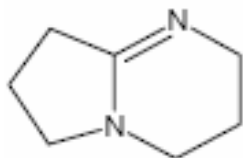
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- Self-assembled monolayers (SAMs) have been used for the functionalization of the silicon surface for CO₂ sensing. The sensing layers contain CO₂ sensitive terminal groups, such as 1,8 diazabicyclo[5,4,0] undec-7-ene (DBU) or 1,5 diaza [3,4,0]-non-5-ene (DBN)*.

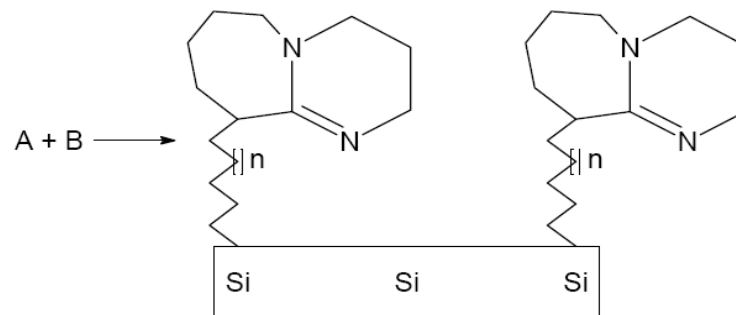
* Bogdan Serban, Cornel Cobianu, Mihai Mihaila, Viorel Dumitru, "Amidines-based monolayers for CO₂ detection by resonant silicon nano-sensors", Docket Number: H0024790, Filing date: 12/11/2009



- The **DBU** structure

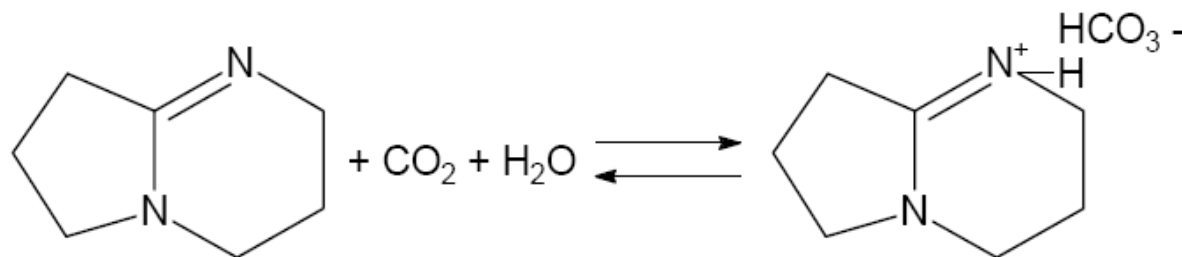


- The **DBN** structure



- Functionalization of silicon surface with **terminal – DBU moieties** for CO₂ sensing

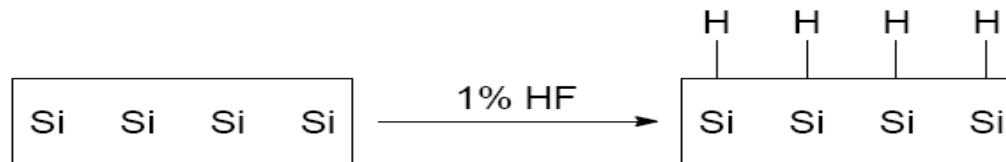
- The chemical reaction responsible for CO₂ sensing



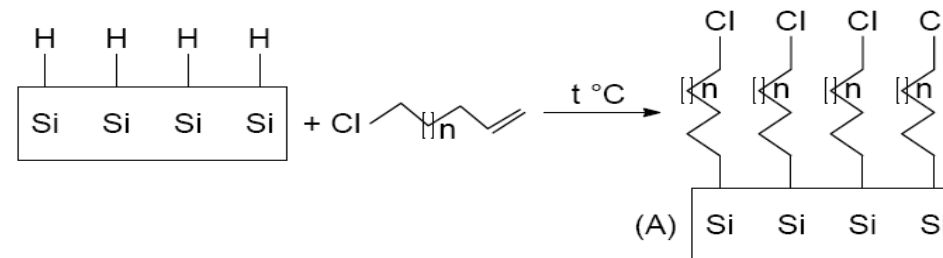
Functionalization for CO₂ – Second approach (2/3)

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- Wafer cleaning avoiding the sticking of the suspended membrane to the substrate
- Native oxide removal from suspended Si beam in 1% HF for obtaining H-terminated Si beam surface



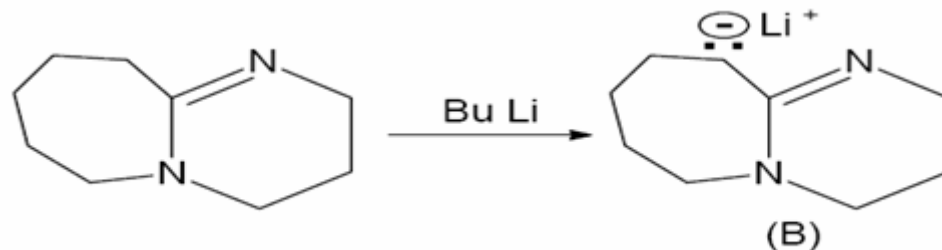
- Immersion of Si-H terminated wafers in a flask containing unsaturated alkyl halide, such as alkyl chloride and toluene, followed by heating the sealed flask for getting a monolayer of this alkyl chloride connected to the Si surface by carbon atoms



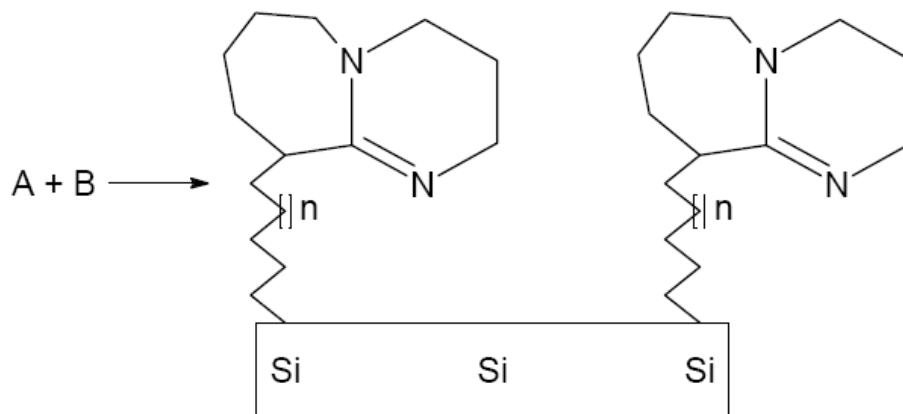
Functionalization for CO₂ – Second approach (3/3)

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- Rinsing the wafers in isopropyl alcohol, followed by their cleaning and drying, so as to avoid the suspended beam sticking to the substrate
- Deprotonation of the DBU in the presence of butyl lithium



- Reaction of deprotonated DBU with alkyl chloride monolayer from the silicon surface



-Reaction of above structure with HCl on the reference beam to get reference layer

- NEMS chemical sensing is able to detect ultra low gas concentrations
- All-differential resonant chemical sensing is proposed as a step forward in NEMS chemical sensing.
- Functionalized sensing layer and reference layer in a differential approach are expected to minimize drift in the response of NEMS chemical sensors.
- Two novel chemical routes are proposed for the all-differential detection of CO₂

Acknowledgements :

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